

<b>Notice of References Cited</b>		Application/Control No. 09/479,999	Applicant(s)/Patent Under Reexamination NAKAMURA ET AL.	
		Examiner Cong-Lac Huynh	Art Unit 2178	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-5,966,535	10-1999	Benedikt et al.	717/147
	B	US-6,098,081	08-2000	Heidorn et al.	707/501.1
	C	US-6,199,071	03-2001	Nielsen, Jakob	707/204
	D	US-5,801,702	09-1998	Dolan et al.	345/854
	E	US-6,138,128	10-2000	Perkowitz et al.	707/501.1
	F	US-5,987,454	11-1999	Hobbs, Allen	707/4
	G	US-6,128,655	10-2000	Fields et al.	709/219
	H	US-6,353,839	03-2002	King et al.	707/513
	I	US-6,178,433	01-2001	Nakamura et al.	707/513
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.